

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q92479

Tsuyoshi UEHARA, et al.

Appln. No.: 10/565,004

Group Art Unit: 1792

Confirmation No.: 5166

Examiner: Keath T CHEN

Filed: January 19, 2006

For: PLASMA PROCESSING APPARATUS AND ELECTRODE STRUCTURE

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 5, 2008, please amend the above-identified application as follows on the accompanying pages.

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